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in AF/2872

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<b>TRANSMITTAL FORM</b>  (to be used for all correspondence after initial filing)	Application Number	09/826,712	
	Filing Date	April 5, 2001	
	First Named Inventor	Johann Engelhardt	
	Art Unit	2872	
	Examiner Name	Nguyen, Thong Q.	
Total Number of Pages in This Submission	38	Attorney Docket Number	21295.23

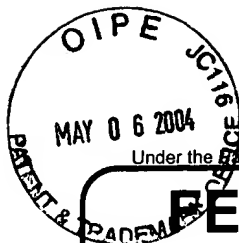
ENCLOSURES (Check all that apply)		
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Firm or Individual	Maria M. Eliseeva
Signature	<i>Maria Eliseeva</i>
Date	May 4, 2004

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Date	May 4, 2004

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

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# FEE TRANSMITTAL for FY 2004

Effective 10/01/2003. Patent fees are subject to annual revision.

☐ Applicant claims small entity status. See 37 CFR 1.27

TOTAL AMOUNT OF PAYMENT (\$ ) 1,280.00

## Complete if Known

Application Number	09/826,712
Filing Date	April 5 2001
First Named Inventor	Dr. Johann Engelhardt
Examiner Name	Nguyen, Thong Q.
Art Unit	2872
Attorney Docket No.	21295.23

## METHOD OF PAYMENT (check all that apply)

☐ Check ☐ Credit card ☐ Money Order ☐ Other ☐ None

☒ Deposit Account:

Deposit Account Number: 502233  
Deposit Account Name: Houston Eliseeva LLP

The Director is authorized to: (check all that apply)

☒ Charge fee(s) indicated below ☒ Credit any overpayments

☒ Charge any additional fee(s) or any underpayment of fee(s)

☐ Charge fee(s) indicated below, except for the filing fee to the above-identified deposit account.

## FEE CALCULATION

### 1. BASIC FILING FEE

Large Entity		Small Entity		Fee Description	Fee Paid
Fee Code	Fee (\$)	Fee Code	Fee (\$)		
1001	770	2001	385	Utility filing fee	
1002	340	2002	170	Design filing fee	
1003	530	2003	265	Plant filing fee	
1004	770	2004	385	Reissue filing fee	
1005	160	2005	80	Provisional filing fee	
SUBTOTAL (1)					(\$ )

### 2. EXTRA CLAIM FEES FOR UTILITY AND REISSUE

Total Claims: 12  
Independent Claims: 1  
Multiple Dependent Claims: 11

Extra Claims Fee from below: 0  
Fee Paid: 0

Large Entity		Small Entity		Fee Description	Fee Paid
Fee Code	Fee (\$)	Fee Code	Fee (\$)		
1202	18	2202	9	Claims in excess of 20	
1201	86	2201	43	Independent claims in excess of 3	
1203	290	2203	145	Multiple dependent claim, if not paid	
1204	86	2204	43	** Reissue independent claims over original patent	
1205	18	2205	9	** Reissue claims in excess of 20 and over original patent	
SUBTOTAL (2)					(\$ )

\*\*or number previously paid, if greater; For Reissues, see above

## FEE CALCULATION (continued)

### 3. ADDITIONAL FEES

Large Entity Small Entity

Fee Code	Fee (\$)	Fee Code	Fee (\$)	Fee Description	Fee Paid
1051	130	2051	65	Surcharge - late filing fee or oath	
1052	50	2052	25	Surcharge - late provisional filing fee or cover sheet	
1053	130	1053	130	Non-English specification	
1812	2,520	1812	2,520	For filing a request for ex parte reexamination	
1804	920*	1804	920*	Requesting publication of SIR prior to Examiner action	
1805	1,840*	1805	1,840*	Requesting publication of SIR after Examiner action	
1251	110	2251	55	Extension for reply within first month	
1252	420	2252	210	Extension for reply within second month	
1253	950	2253	475	Extension for reply within third month	950.00
1254	1,480	2254	740	Extension for reply within fourth month	
1255	2,010	2255	1,005	Extension for reply within fifth month	
1401	330	2401	165	Notice of Appeal	
1402	330	2402	165	Filing a brief in support of an appeal	330.00
1403	290	2403	145	Request for oral hearing	
1451	1,510	1451	1,510	Petition to institute a public use proceeding	
1452	110	2452	55	Petition to revive - unavoidable	
1453	1,330	2453	665	Petition to revive - unintentional	
1501	1,330	2501	665	Utility issue fee (or reissue)	
1502	480	2502	240	Design issue fee	
1503	640	2503	320	Plant issue fee	
1460	130	1460	130	Petitions to the Commissioner	
1807	50	1807	50	Processing fee under 37 CFR 1.17(q)	
1806	180	1806	180	Submission of Information Disclosure Stmt	
8021	40	8021	40	Recording each patent assignment per property (times number of properties)	
1809	770	2809	385	Filing a submission after final rejection (37 CFR 1.129(a))	
1810	770	2810	385	For each additional invention to be examined (37 CFR 1.129(b))	
1801	770	2801	385	Request for Continued Examination (RCE)	
1802	900	1802	900	Request for expedited examination of a design application	

Other fee (specify)

\*Reduced by Basic Filing Fee Paid

SUBTOTAL (3) (\$ ) 1,280.00

## SUBMITTED BY

(Complete if applicable)

Name (Print/Type)	Maria M. Eliseeva	Registration No. (Attorney/Agent)	43,328	Telephone	781-863-9991
Signature		Date	May 4, 2004		

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re:	Johann Engelhardt, et al.	Confirmation No:	3955
Serial No:	09/826,712	Group:	2872
Filed:	April 5, 2001	Examiner:	Nguyen, Thong Q.
For:	Double Confocal Scanning Microscope		

**APPEALANTS' BRIEF**

Mail Stop Appeal Brief- Patents  
**Assistant Commissioner for Patents**  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This is the Applicants' appeal from the final Office Action, mailed July 31, 2003,  
(Paper No. 21).

A three month extension of time is requested for this response.

**Real Party of Interest**

Leica Microsystems Heidelberg GmbH is the real party in interest.

**Related Appeals and Interferences**

There are no related appeals or interferences.

**Status of Claims**

Claims 1-4, 8-10 and 16-20 are pending in this application. Claims 1-4, 8-10 and 16-20 stand more than twice rejected pursuant to the outstanding Office Action.

**Status of Amendments**

All amendments have been entered. There were no post final amendments or proposed amendments.

05/07/2004 AWONDAF1 00000024 502233 09826712

01 FC:1402	330.00 DA
02 FC:1253	950.00 DA

## **Summary of the Invention**

According to the present invention, the optical properties of the components arranged in the beam path are coordinated with one another in such a way that the accumulated aberrations are at least of the order of magnitude of the theoretically achievable resolution capability. The sum of one type of aberration in the components to be incorporated into an optical calculation constitutes the accumulated aberrations. The theoretically achievable resolution capability in the context of a double confocal scanning microscope depends, like the resolution capability of a conventional microscope, on the wavelength of the light and the numerical aperture of the microscope objective being used. In a typical fluorescence application in the biomedical field, the lateral resolution capability of a confocal scanning microscope is approx. 200 nm, and the axial resolution capability approx. 600 to 800 nm. The term "lateral resolution" will be used hereinafter to refer to the resolution in the focal plane. The lateral resolution capability of a double confocal scanning microscope is substantially the same as that of a confocal scanning microscope, but the axial resolution capability of a double confocal scanning microscope lies in a range of approx. 100 to 200 nm. In order to achieve a maximum resolution capability, it is thus the values of the theoretical resolution capability of a double confocal scanning microscope which define the order of magnitude of the coordination range of the components of the double confocal scanning microscope according to the present invention arranged in the beam path. This order of magnitude of the coordination range can, however, fluctuate by a factor of as much as 10, depending on the demands placed on the double confocal scanning microscope. Coordination of the components arranged in the beam path can accordingly be accomplished in such a way that the accumulated aberrations, for example in the axial direction, lie between 10 and 1,000 nm.

## **Issues**

- I. Whether Claims 1-3, 8-9, and 19-20 are patentable under 35 U.S.C. 103(a) over Hell (EP No. 491289, "Hell") in view of Picard (U.S. Patent No. 4,965,441, "Pickard").
- II. Whether Claims 1-4, 8-9, and 19-20 are patentable under 35 U.S.C. 103(a) over Schoppe (DE 39 18 412, "Schoppe") in view of Picard.

- III. Whether Claims 10 and 16-18 are patentable under 35 U.S.C. 103(a) over Hell in view of Picard as applied to Claim 1 and further in view of Stern et al. (U.S. Patent 5,790,242).

### **Grouping of Claims**

Claims 1-4, 8-10 and 16-20 stand or fall separately.

### **Argument**

- I. Whether Claims 1-3, 8-9, and 19-20 are patentable under 35 U.S.C. 103(a) over Hell (EP No. 491289, "Hell") in view of Picard (U.S. Patent No. 4,965,441, "Pickard").**

In order for an obviousness rejection to be proper, the Patent Office must meet the burden of establishing a prima facie case of obviousness. The Patent Office must meet the burden of (1) establishing that all elements of the invention are disclosed in the cited publications, which (2) must have a suggestion, teaching or motivation for one of ordinary skill in the art to modify a reference or combined references.<sup>1</sup> The cited publications should (3) explicitly provide a reasonable expectation of success, determined from the position of one of ordinary skill in the art at the time the invention was made.<sup>2</sup>

(1) One of the main features of this invention, as reflected in pending Claim 1, is that the two microscope objectives are corrected and that the longitudinal chromatic aberrations are so corrected by the two oppositely disposed objectives that the resolution of the microscope is in the order of magnitude of the theoretically achievable resolution. The specification and dependent Claim 20 further specify that the theoretical achievable resolution of the present double confocal microscope is about 100 nm.

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<sup>1</sup> *In re Sang Su Lee*, 277 F.3d 1338, 61 USPQ2d 1430 (Fed. Cir. 2002).

<sup>2</sup> *In re Fine*, 5 U.S.P.Q.2d 1596, 1598 (Fed. Cir. 1988); *In re Wilson*, 165 U.S.P.Q. 494, 496 (C.C.P.A. 1970);

*Amgen v. Chugai Pharmaceuticals Co.*, 927 U.S.P.Q.2d, 1016, 1023 (Fed. Cir. 1996);

The above-described feature of the present invention could not be found in the Hell published application. The microscope in Hell uses the illuminating light of one wavelength  $\lambda$ , so Hell does not teach color correction in his microscope and, for the same reason, does not teach corrected microscope objectives specifically for correction of longitudinal chromatic aberrations. Needless to say, since the Hell microscope uses the light of one wavelength  $\lambda$ , no teaching with regard to color correction in the two microscope objectives leading to the resolution up to the theoretically achievable, as claimed in Claim 1, could be found in Hell. Since no color (no longitudinal chromatic aberration) correction takes place in the Hell microscope, the Patent Office is incorrect in its assertion that “the optical components disclosed in the double scanning microscope of Hell inherently possess such characteristics”.

Moreover, in support of its assertion that all the limitation of Claim 1 can be found in Hell, the Patent Office wrote that “a laser” is understood as a light containing different wavelengths...” It is known that a laser beam is generated due to the stimulated emission which forces the electrons to transition to a lower energy level from a higher energy level. As a result of the stimulated emission the laser beam is highly monochromatic and is characterized by one specific wavelength, which is determined by the amount of energy released during the transition to the lower energy level. Therefore, the Patent Office is incorrect in its assertion that the Hell microscope inherently contains illumination with different wavelength. The reference to fluorescent microscopy and a color beam splitter on page 4, column 5 of Hell, mentioned by the Patent Office, has nothing to do with illuminating the specimen with light of different wavelengths. The color beam splitter in Hell has to do with separating the excitation (shorter) and florescence (longer) wavelengths to separate detection light from illumination/excitation light. The excitation-fluorescent wavelength disparity is fundamental to the phenomenon of fluorescence and has nothing to do with illuminating the specimen with the light of more than one wavelength. Therefore nothing in Hell suggests explicitly or inherently that light of more than one wavelength can be used to illuminate the specimen in a color corrected fashion via two color corrected microscope objectives that reduce the longitudinal chromatic aberrations to the extent that the resolution along the optical axis approaches the theoretically achievable resolution, as claimed in Claim 1.

The Patent Office also cites Picard in support of its conclusion that “an illumination system in a scanning microscope having a laser of different wavelengths is known to one skilled in the art”. Further it is asserted that “as a result of use laser [sic] having different wavelengths for illuminating a specimen in the system of Hell then the light passing through the opposite objectives will focus on particular focal length dependent upon wavelengths of light”.

This conclusion is unwarranted and has nothing to do with the invention claimed in Claim 1 and its dependent claims. First of all, merely the fact that the refractive index of a material (a lens) is wavelength dependent, and that because of the dispersion of polychromatic light the components of the longer wavelength focus further away from the lens alone, is not the essence of Claim 1. The lens in Picard is uncorrected for chromatic aberrations, and that uncorrected lens generates a plurality of focal points due to natural dispersion of light of different wavelengths. Col. 5, lines 23-33. Such various focal points allow the optical system in Picard to carry out in-depth 2-dimensional scanning of a specimen without sequential acquisition to the depth of about 0.5 micron.

The three focal planes of the present invention, such as claimed in Claims 1, 3 and 9, cannot be compared to the focal planes of Picard. The focal points on three planes of the present invention, corresponding to the light of three different wavelengths, are not the result of natural dispersion, as in Picard, but are the result of correction of longitudinal chromatic aberrations achieved by the oppositely spaced corrected microscope objectives. The two corrected microscope objectives focus the three light beams of different wavelengths to the focal points (planes) disposed so close to each other that the axial resolution of the microscope approaches the theoretical value, as claimed in Claim 1. An axial resolution approaches the theoretical value for a polychromatic light beam when various light components of different wavelength focus essentially onto the same plane, or the planes located so close to each other that the resolution remains at least of the order of magnitude of the theoretical value. Which is what is claimed in Claim 1 with regard to the resolution of the microscope. Evidently, the description of Picard in which one uses a non-corrected lens to generate a plurality of focusing points due to dispersion in the material is exactly the opposite of the claimed

invention, which needs corrected microscope objectives to achieve the claimed resolution.

Also, the system of Picard combined with the oppositely spaced corrected microscope objectives in Hell will not result in the system as claimed in Claim 1, contrary to what is asserted by the Patent Office. The uncorrected lens in Picard will not focus the light to three different focal planes for the microscope resolution to be within the theoretical value, as claimed in Claims 1, 3 and 9. Therefore neither Picard nor Hell nor their combination discloses all elements of the invention and the first prong of the legal standard of obviousness is not met.

(2) Since neither Picard nor Hell discloses “the two corrected microscope objectives have optical properties and are arranged opposite of each other relative to a specimen, so that the longitudinal chromatic aberrations of the two corrected microscope objectives with respect to the optical axis are almost identical for the two microscope objectives, and wherein a resolution of the microscope is at least the order of magnitude of a theoretically achievable resolution of the microscope” element of the invention as claimed in independent Claim 1, combining Picard and Hell does not disclose such element either.

Moreover, in accordance with *In re Lee*, the burden is on the Patent Office to point out where in Hell or Picard there is a suggestion or motivation to combine them to come up with the claimed invention. Nowhere either in Hell or Picard or their combination could a suggestion, teaching or motivation be found for one of ordinary skill in the art to modify a reference or combined references to come up with the invention as claimed. Therefore, the Patent Office has not met its burden of proof and prong (2) of the obviousness test is not met.

(3) Similarly, since neither Picard nor Hell nor their combination discloses all the elements of the claimed invention and provides no teaching or suggestion or motivation to combine Hell and Picard to come up with the claimed invention, the Patent Office could not point out to where these patents explicitly provide a reasonable expectation of success, determined from the position of one of ordinary skill in the art at the time the



invention was made. Therefore, the third prong of the legal test for obviousness is not met.

Therefore, Claims 2-3, 8-9 and 19-20 are patentable, the rejection should be withdrawn and Claim 1 and its dependent Claims 2-3, 8-9 and 19-20 should be allowed.

**II. Whether Claims 1-4, 8-9, and 19-20 are patentable under 35 U.S.C. 103(a) over Schoppe (DE 39 18 412, “Schoppe”) in view of Picard.**

In order for an obviousness rejection to be proper, the Patent Office must meet the burden of establishing a prima facie case of obviousness. The Patent Office must meet the burden of (1) establishing that all elements of the invention are disclosed in the cited publications, which (2) must have a suggestion, teaching or motivation for one of ordinary skill in the art to modify a reference or combined references.<sup>3</sup> The cited publications should (3) explicitly provide a reasonable expectation of success, determined from the position of one of ordinary skill in the art at the time the invention was made.<sup>4</sup>

(1) Similarly to the arguments presented in Section I, which are repeated and incorporated into this Section in their entirety, the Applicant reiterates that the Shoppe microscope uses the light of one wavelength  $\lambda$ . No teaching with regard to color correction in the two microscope objectives leading to the resolution up to the theoretically achievable, as claimed in Claim 1, could be found in Shoppe. Since no color (no longitudinal chromatic aberration) correction takes place in the Shoppe microscope, the Patent Office is incorrect in its assertion that “the optical components disclosed in the double scanning microscope of Shoppe inherently possess such characteristics”.

Moreover, the three focal planes of the present invention, such as claimed in Claims 1, 3 and 9, cannot be compared to the focal planes of Picard for the same reasons as explained in Section I. The uncorrected lens in Picard will not focus the light to three

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<sup>3</sup> *In re Sang Su Lee*, 277 F.3d 1338, 61 USPQ2d 1430 (Fed. Cir. 2002).

<sup>4</sup> *In re Fine*, 5 U.S.P.Q.2d 1596, 1598 (Fed. Cir. 1988); *In re Wilson*, 165 U.S.P.Q. 494, 496 (C.C.P.A. 1970);

*Amgen v. Chugai Pharmaceuticals Co.*, 927 U.S.P.Q.2d, 1016, 1023 (Fed. Cir. 1996);

different focal planes for the microscope resolution to be within the theoretical value, as claimed in Claims 1, 3 and 9. Therefore neither Picard nor Shoppe nor their combination discloses all elements of the invention and the first prong of the legal standard of obviousness is not met.

(2) Since neither Picard nor Shoppe discloses “the two corrected microscope objectives have optical properties and are arranged opposite of each other relative to a specimen, so that the longitudinal chromatic aberrations of the two corrected microscope objectives with respect to the optical axis are almost identical for the two microscope objectives, and wherein a resolution of the microscope is at least the order of magnitude of a theoretically achievable resolution of the microscope” element of the invention as claimed in independent Claim 1, combining Picard and Shoppe does not disclose such element either.

Moreover, in accordance with *In re Lee*, the burden is on the Patent Office to point out where in Shoppe or Picard there is a suggestion or motivation to combine them to come up with the claimed invention. Nowhere either in Shoppe or Picard or their combination could a suggestion, teaching or motivation be found for one of ordinary skill in the art to modify a reference or combined references to come up with the invention as claimed. Therefore, the Patent Office has not met its burden of proof and prong (2) of the obviousness test is not met.

(3) Similarly, since neither Picard nor Shoppe nor their combination discloses all the elements of the claimed invention and provides no teaching or suggestion or motivation to combine Shoppe and Picard to come up with the claimed invention, the Patent Office could not point out where these patents explicitly provide a reasonable expectation of success, determined from the position of one of ordinary skill in the art at the time the invention was made. Therefore, the third prong of the legal test for obviousness is not met.

Therefore, Claims 2-4, 8-9 and 19-20 are patentable, the rejection should be withdrawn and Claim 1 and its dependent Claims 2-4, 8-9 and 19-20 should be allowed.

**III. Whether Claims 10 and 16-18 are patentable under 35 U.S.C. 103(a) over Hell in view of Picard as applied to Claim 1 and further in view of Stern et al. (U.S. Patent 5,790,242).**

In order for an obviousness rejection to be proper, the Patent Office must meet the burden of establishing a prima facie case of obviousness. The Patent Office must meet the burden of (1) establishing that all elements of the invention are disclosed in the cited publications, which (2) must have a suggestion, teaching or motivation for one of ordinary skill in the art to modify a reference or combined references.<sup>5</sup> The cited publications should (3) explicitly provide a reasonable expectation of success, determined from the position of one of ordinary skill in the art at the time the invention was made.<sup>6</sup>

(1)-(3) Applicant repeats and incorporates the arguments presented in Sections I and II in their entirety. It has been established that the Patent Office has not met its burden of proof that independent Claim 1 is obvious under the legal obviousness test over Hell in view of Picard. If independent Claim 1 is non-obvious, it is axiomatic that its dependent Claims 10 and 16-18 are non obvious. Therefore, 10 and 16-18 are patentable, the rejection should be withdrawn and Claims 10 and 16-18 should be allowed.

Respectfully submitted,

By Maria M. Eliseeva  
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Date: May 4, 2004

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<sup>5</sup> *In re Sang Su Lee*, 277 F.3d 1338, 61 USPQ2d 1430 (Fed. Cir. 2002).

<sup>6</sup> *In re Fine*, 5 U.S.P.Q.2d 1596, 1598 (Fed. Cir. 1988); *In re Wilson*, 165 U.S.P.Q. 494, 496 (C.C.P.A. 1970);

*Amgen v. Chugai Pharmaceuticals Co.*, 927 U.S.P.Q.2d, 1016, 1023 (Fed. Cir. 1996);

## Appendix

1. (Currently amended) A double confocal scanning microscope for examining a specimen, the microscope comprising:

at least one light source defining an illuminating beam path and emitting coherent light of various wavelengths;

at least one detector defining detection beam path; and

two corrected microscope objectives defining an optical axis, a beam splitter, and a lens arranged in the illuminating beam path and the detection beam path,

wherein the two corrected microscope objectives have optical properties and are arranged opposite of each other relative to a specimen, so that the longitudinal chromatic aberrations of the two corrected microscope objectives with respect to the optical axis are almost identical for the two microscope objectives, and wherein a resolution of the microscope is at least the order of magnitude of a theoretically achievable resolution of the microscope.

2.(Currently amended) The scanning microscope as defined in Claim 1, wherein the longitudinal chromatic aberrations of the two corrected microscope objectives are reduced with regard to a second plane being at least partially coincident with a focal plane of the two microscope objectives for light of a second wavelength.

3. (Currently amended) The scanning microscope as defined in Claim 2 4, wherein the second plane is symmetrically disposed between a first and a third planes, wherein the first plane is a focal plane of light of a first wavelength and wherein the third plane is a focal plane of light of a third wavelength.

4. (Currently amended) The scanning microscope as defined in Claim 1, characterized in that a the beam splitter of an interferometer is provided in the illuminating beam path and the detection beam path, thereby defining a first and a second individual partial beam paths wherein along which the accumulated aberrations of the of the interferometer are made opposite to one another.

5. (Cancelled)

6. (Cancelled)

7. (Cancelled)

8. (Currently amended) The scanning microscope as defined in Claim 3 ~~4~~, wherein reduction of the chromatic aberrations occurs for the light of the first, second and third wavelengths selected from a wavelength range from about 200 nm to about 2000 nm.

9. (Currently amended) The scanning microscope as defined in Claim 3 ~~4~~, wherein polarization properties of the two microscope objectives disposed along ~~an~~ the optical axis, ~~a~~ the beam splitter, and ~~a~~ the lens are coordinated with one another in such a way that the light of the first, second and third wavelengths is focused on the first, second and third plane accordingly.

10. (Previously amended) The scanning microscope as defined in Claim 1, further comprising a detection pinhole and a dichroic beam splitter detecting the illumination beam path, wherein a position of at least the dichroic beam splitter or a position of at least the detection pinhole can be altered.

11. (Cancelled)

12. (Cancelled)

13. (Cancelled)

14. (Cancelled)

15. (Cancelled)

16. (Previously amended) The scanning microscope as defined in Claim 10, wherein the detection pinhole is embodied as at least one chromatically selective component.

17. (Previously amended) The scanning microscope as defined in Claim 16, wherein at least one chromatically selective component is provided for each detected wavelength region.

18. (Previously amended) The scanning microscope as defined in Claim 16, further comprising a multi-band detector disposed after the chromatically selective component.

19. (Currently amended) The scanning microscope of Claim 3 4, wherein the first wavelength is about 488 nm, the second wavelength is about 567 nm, and the third wavelength is about 647 nm.

20. (Previously added) The scanning microscope of Claim 1, wherein the theoretically achievable resolution capability of the microscope is about 100 nm.